

GP1463 \$



**TRANSMITTAL LETTER**  
**(General - Patent Pending)**

Docket No.  
11675.114

In Re Application of Kei-Yu Ko



Serial No. 08/846,671	Filing Date April 30, 1997	Examiner George Goudreau	Group Art Unit 1763
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Title: **UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Transmittal Letter (1 pg. in duplicate); Transmittal of Information Disclosure Statement (2 pgs. in duplicate);  
Information Disclosure Citation (1 pg.); Information Disclosure Statement (2 pgs.); PTO-2038 in the amount of  
\$240.00; postcard.

in the above identified application.

- ☐ No additional fee is required.
- ☒ A check in the amount of \$240.00 is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. as described below. A duplicate copy of this sheet is enclosed.
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23-3178

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Bradley K. DeSandro  
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I certify that this document and fee is being deposited on <u>October 3, 2000</u> with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.	
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